



Att'y. Dkt. No. APPM/002622.D1/CMP/ECP/RKK

In re Application of:  
Dordi, et al.

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**Group Art Unit: 1753**

**Examiner:** Edna Wong

For: **Electro-Chemical  
Deposition Cell for Face-Up  
Processing of Single  
Semiconductor Substrates**

MAIL STOP RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on August 12, 2005 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV335477709US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 12, 2005  
Date

**Brian K. Hrna**

## PRELIMINARY AMENDMENT

Prior to a continuing examination, please amend the above identified application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.